



Docket No.: 1739-0175P
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Berthold KESSLER et al.

Application No.: 10/633,662

Confirmation No.: 005312

Filed: August 5, 2003

Art Unit: 2877

For: METHOD AND SENSOR DEVICE FOR
MONITORING A LASER MACHINING
OPERATION TO BE PERFORMED ON A
WORK PIECE AS WELL AS LASER
MACHINING HEAD WITH A SENSOR
DEVICE OF THIS KIND

Examiner: M. P. Stafira

REPLY AFTER FINAL ACTION (37 C.F.R. SECTION 1.116)

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

INTRODUCTORY COMMENTS

In response to the Examiner's Office Action dated June 6, 2005 finally rejecting claims 1 and 3-5, and with the due date for response having been Petitioned to be extended one month to October 6, 2005, the following remarks are respectfully submitted in connection with the above-identified application.

Remarks/Arguments begin on page 2 of this paper.